

Notice of References Cited	Application/Control No. 10/724,671	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Richard Chan	Art Unit 2685	Page 1 of 1

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*	B	US-2001/0016508	08-2001	Kido et al.	455/575
*	C	US-2006/0035680	02-2006	Kokubo, Takeshi	455/566
*	D	US-2006/0019728	01-2006	Sakamoto et al.	455/575.3
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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